

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				Docket Number (Optional) <b>END920030127US1</b>		Application Number		
				Applicant(s) <b>C. N. Kline</b>				
				Filing Date <b>Herewith</b>		Group Art Unit		
<b>U.S. PATENT DOCUMENTS</b>								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
/AFT/		US 2002/0026591 A1	2/28/02	B. V. Hartley et al	713	201	04/12/01	
↓		US 2002/0095591 A1	7/18/02	W. T. anielle t al	713	200	01/12/01	
		US 2003/0115446 A1	06/19/03	K. D. Simon et al	713	100	12/17/01	
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/AFT/		6,233,576	05/15/01	J. R. Lewis	707	9	09/25/95	
<b>FOREIGN PATENT DOCUMENTS</b>								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>								
/AFT/		ION Secure TM 3500 G2-SIE, ION Netowrks, Inc., Piscataway, NJ 2002						
		MQSeries Planning Guide, IBM Corp. 1999						
/AFT/		Candle Corp's MQSecure, EAI Journal, Jun 2002, <a href="http://www.bijonline.com/PDF/FIMQSecure.pdf">http://www.bijonline.com/PDF/FIMQSecure.pdf</a> .						
EXAMINER <b>/Amare Tabor/</b>				DATE CONSIDERED <b>08/15/2007</b>				
<b>EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</b>								